# INPUTS & REQUIREMENTS FOR THE FORWARD PHOTON DETECTOR SYSTEM

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06/05/19

LUXE weekly technical meetings

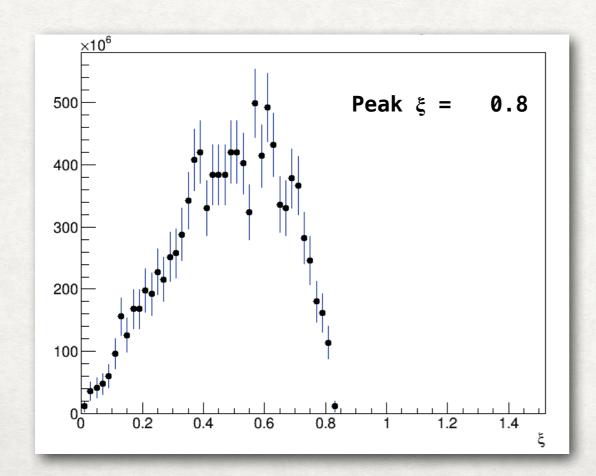


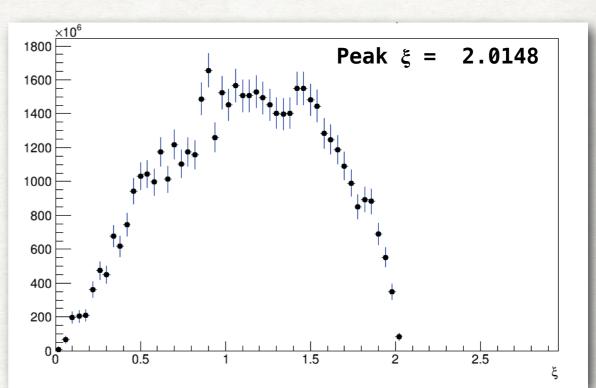
## PHOTONS FROM MC

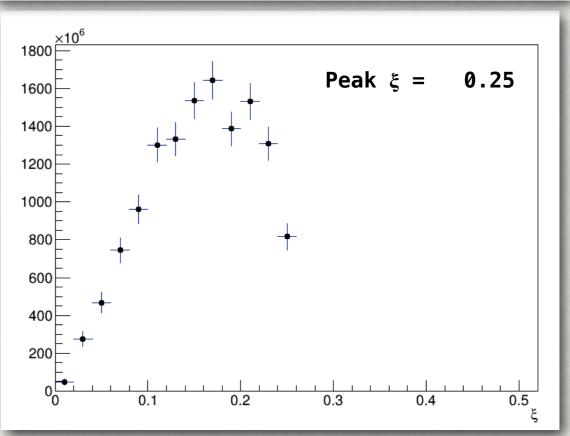
#### LASER INTENSITY

MC simulation provides information for  $\xi$  for each individual interaction

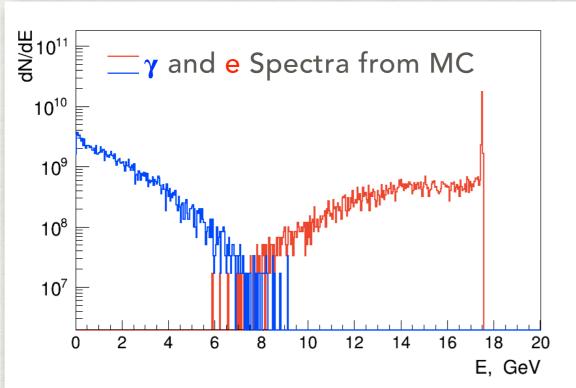
- •Realistic simulation of laser pulse intensity distribution.
- The field is not the same across the laser pulse.



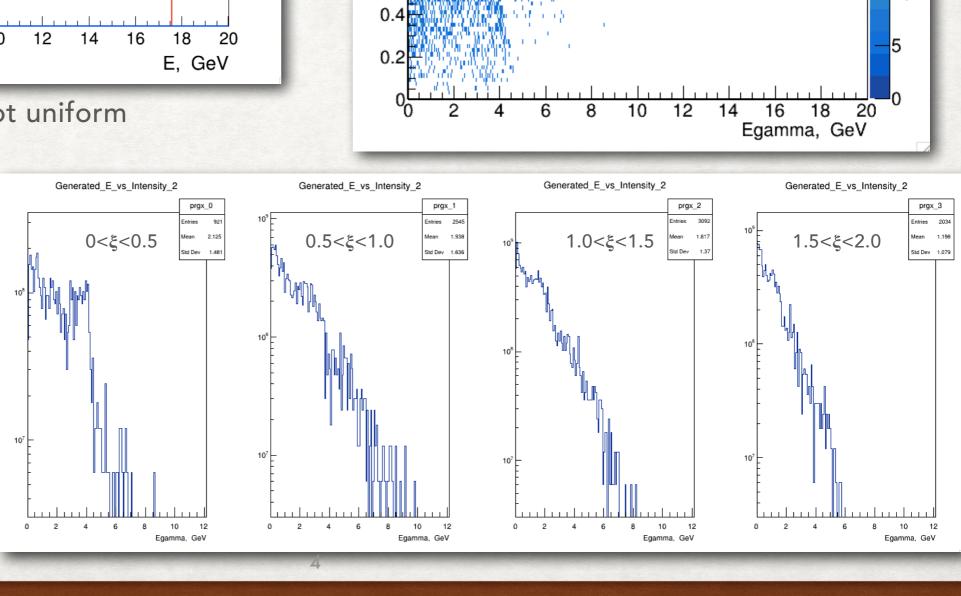




#### ξ VS E<sub>γ</sub> FROM MC



- Laser Intensity ( $\xi$ ) is not uniform
- This makes the kinematic edges from different n not visible
- ξ distribution might be reconstructed by fitting measured spectra w/ convolution of HICS xsection & ξ trial distribution



Generated\_E\_vs\_Intensity\_2

Peak  $\xi$  =

40

35

30

25

20

15

10

Mean x

Std Dev x

2.0148

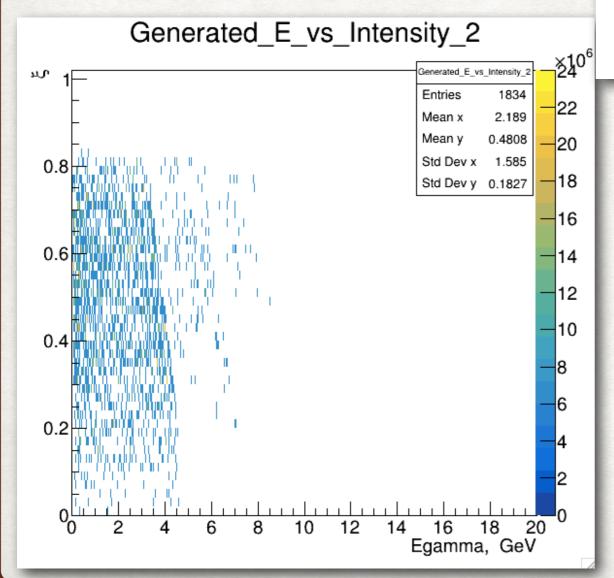
Std Dev y 0.4551

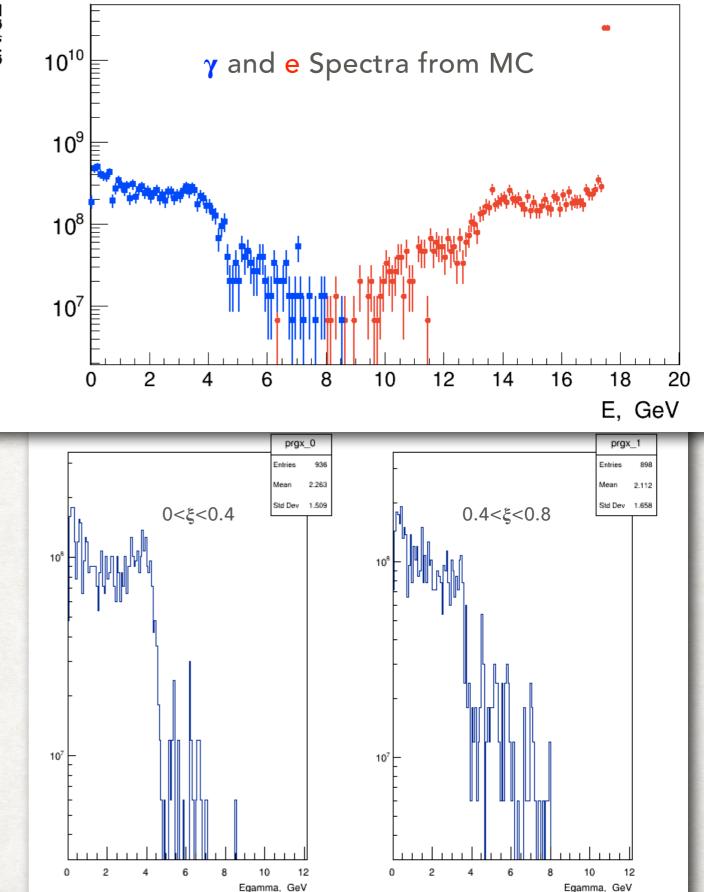
1.666

### ξ VS E<sub>γ</sub> FROM MC

Peak  $\xi = 0.8$ 

The kinematic edges can be seen at the low intensity.

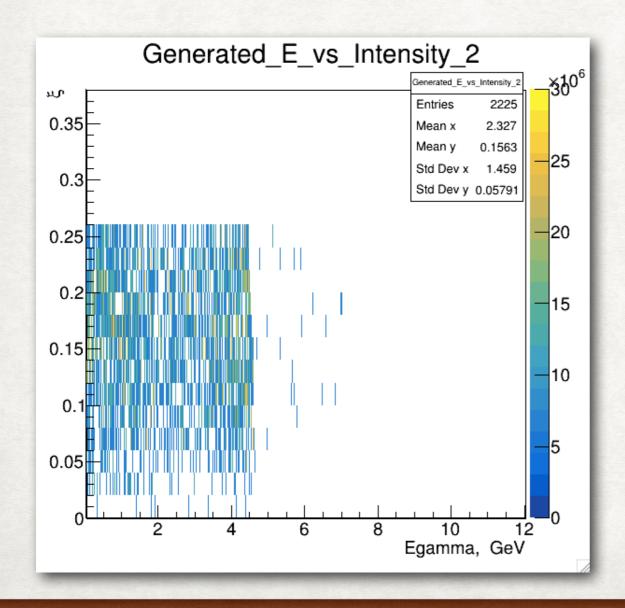


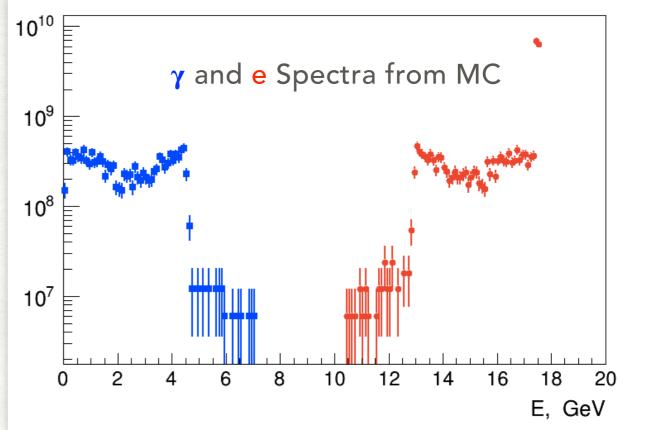


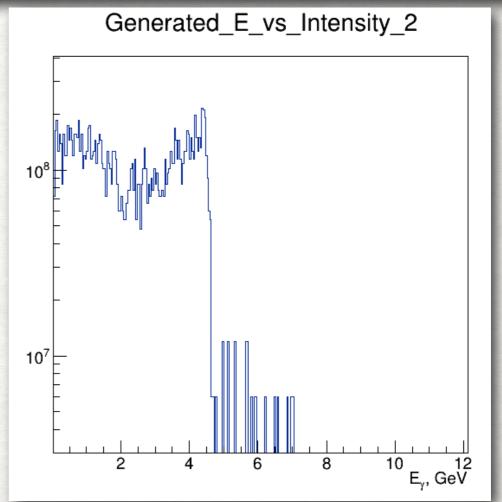
#### ξ VS E<sub>γ</sub> FROM MC

Peak  $\xi = 0.25$  0.01 J

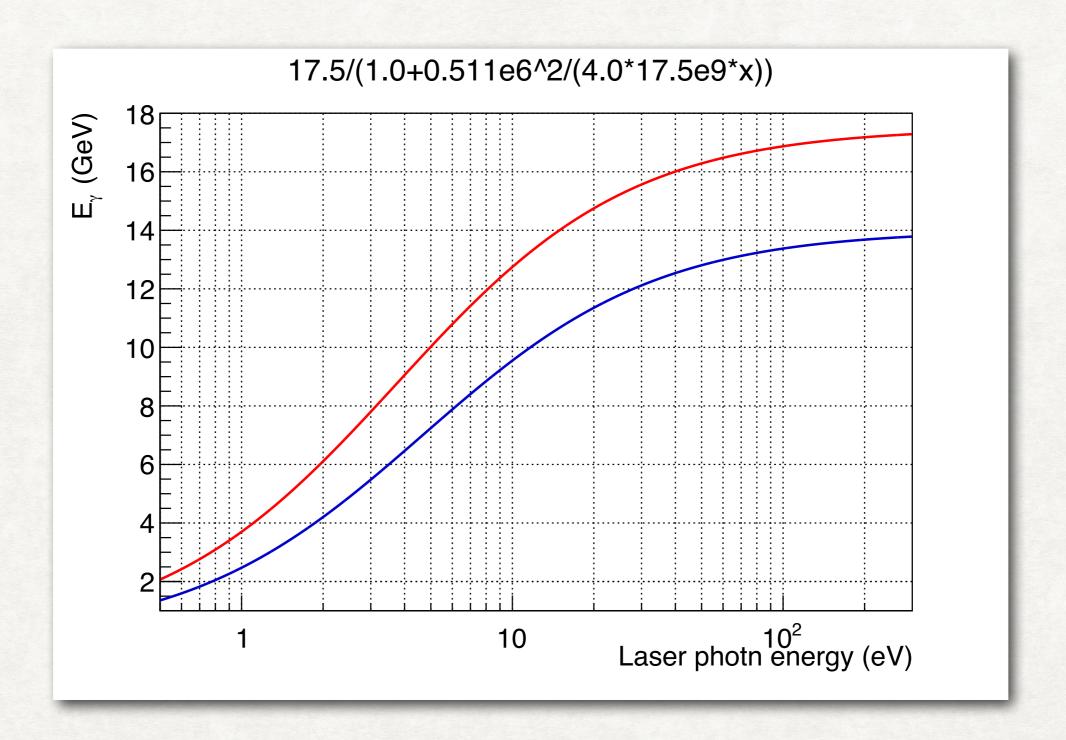
The first kinematic edge is seen very profoundly but higher n are not seen at all







### COMPTON EDGE FROM CALCULATIONS



For 800nm laser: Copmton edge ~ 5.137019 GEV

#### DETECTOR REQUIREMENTS



- Tasks at hand

  a) measure number of photons
  b) measure energy spectrum
- Number of photons for HICS process for different  $\xi$  (for 0.1 and 0.6) for XFEL beam (6.0e+09) gives 1e+10 and 5e+10 correspondingly
- CONSIDERING Number of particles (e- or e+) in detector to be ~ 1e+3
- Then the target is supposed to be ~1e-6 X0
  - \* Jet Gas Target
  - \* Thin Wire Target ~1e-3 X0 which geometry makes angular selection
  - \* Metal Micro-strip Detector?
- It is possible to decrease the nominal number of e- in a bunch down to 6.0e+7 with special gun tuning

#### METAL MICRO-STRIP DETECTOR AS A TARGET ?

MMD is a  $\sim 1.0\,\mu m$  thick semi-transparent radiation hard micro-strip detector designed (KINR) for non-destructive online beam profile monitoring

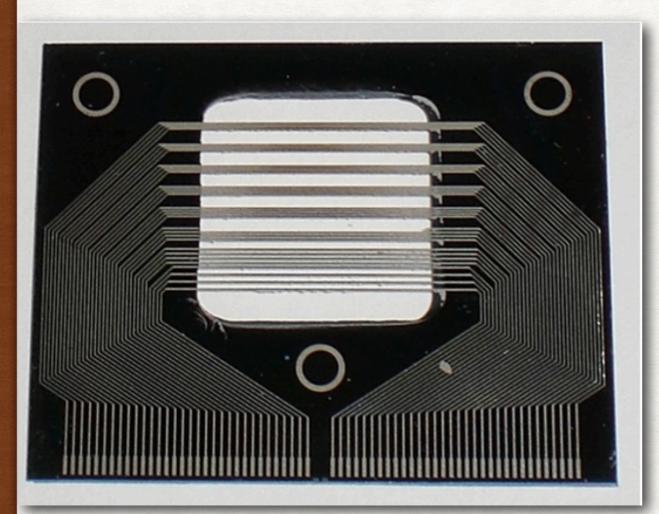


Photo of the MMD with variable pitch (8 groups of strips with pitch varying from 3 to 300 µm)

The current technology allows for production of the thin ( $\sim$ 1 µm) Ni-strips with a pitch of  $\sim$  few µm, providing high position resolution. MMD advantages are:

- $\bullet$  extremely low thickness of sensor (~ 1 µm) unreachable in other types of microdetectors;
- high radiation resistance (>100 MGy);
- transparency for charged particle beams (transmittance up to 90%) allows for including MMD into a feedback system for focusing and stabilization of a beam;
- low operational voltage (20 V);
- high spatial resolution (5...25 μm);
- unique, well-developed production technology;
- commercially available read-out hardware and software;

9

#### **TESTS**

32 MeV alpha-particles beam at Tandem generator for single events upset studies of the BEETLE chip (MPIfK, Heidelberg)

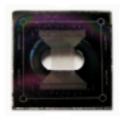
The MMD was applied successfully for the X-rays beam profile monitoring at HASYLAB (DESY, Hamburg) [4]. MMD (32 Ni strips, 70  $\mu$ m pitch, 2  $\mu$ m thickness) has been introduced into the 15 keV X-ray beam (4.5·10<sup>14</sup> photons/second/mm2). The conversion factor has been evaluated as 1.5·10<sup>4</sup> photons/e.



MMD: 16 sectors, 1  $\mu m$  thick



MMD: 64 strips, 100 μm pitch, 40 μm width, 1 μm thick



MMD: 128 strips, 30 μm pitch, 10 μm width, 1 μm thick

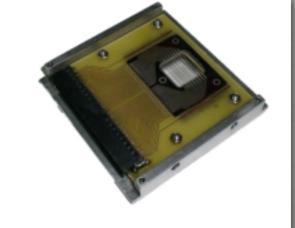


MMD: 1024 strips, 60 μm pitch, 40 μm width, 1,5 μm thick



MMD Variable Step: 32 strips, 8 groups, 2-300 μm dist., 100 μm width, 1,5 μm thick



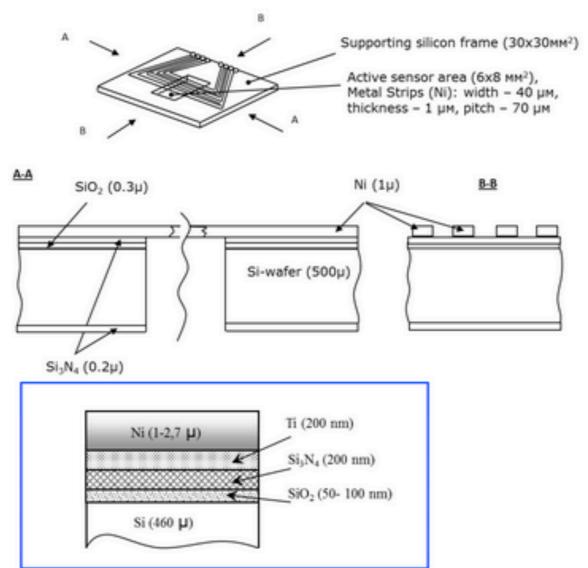






#### Production technology

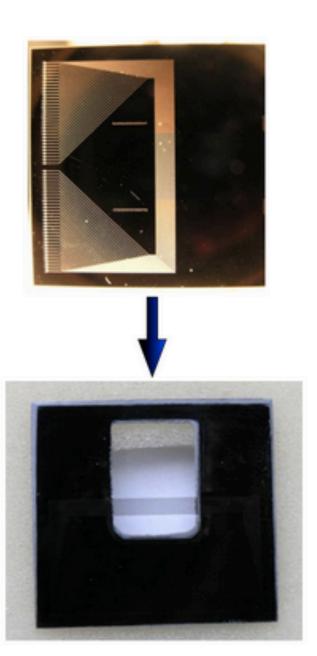




#### PRODUCTION TECHNOLOGY

The sensors were prepared by means of microelectronics technology and plasma-chemistry etching. Nickel layers served as films for the photo-lithography shaping of the strip pattern as well as contacting lines and pads. From the back side of the sensor a window was created for the plasma-chemistry etching. The KINR plasma-chemical reactor with variable ion energy has been used.

The strips were bonded to the ceramics based pitch adapter and connected by a flexible kapton isolated cable to the 50-pin connector.



Metal strip sensor is the only object interacting with the radiation beam in the working area

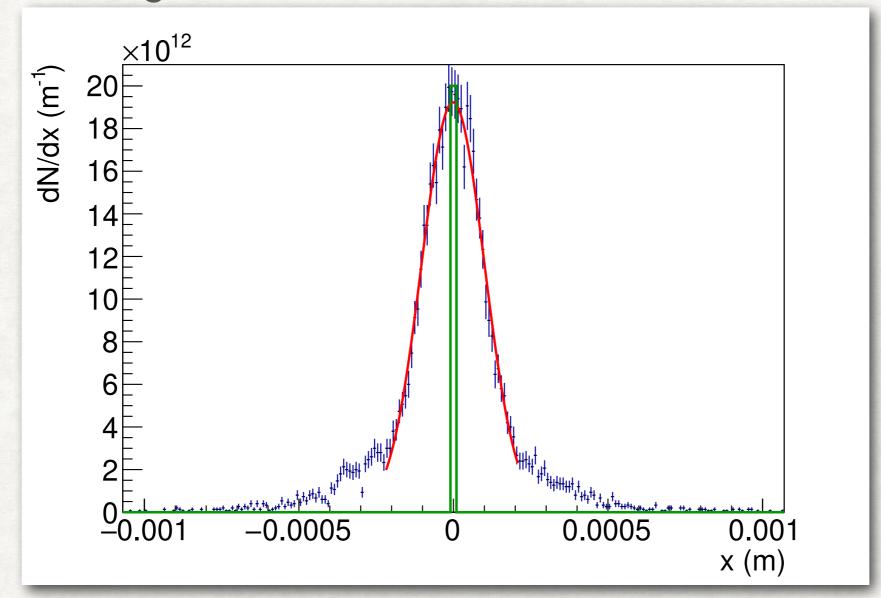
```
The run was 12421001 gamma of 17.5 GeV through 10 um of Tungsten (density: 19.3 g/cm3 )
Total energy deposit in absorber per event = 2.033 eV +- 0.06957 eV
----> Mean dE/dx = 0.002033 \text{ MeV/cm} (0.0001053 MeV*cm2/g)
From formulas:
  restricted dEdx = 0 \text{ MeV/cm} (0 \text{ MeV*cm2/q})
  full dEdx
                 = 0 \text{ MeV/cm} (0 MeV*cm2/q)
Leakage: primary = 2.126 GeV +- 407.6 keV secondaries = 289.8 keV +- 6.85 keV
Energy balance : edep + eleak = 2.126 GeV
Total track length (charged) in absorber per event = 1.087 nm +- 3.31e+04 fm
Total track length (neutral) in absorber per event = 583.5 nm +- 6.164 Ang
Number of steps (charged) in absorber per event = 0.001229 +- 5.162e-08
Number of steps (neutral) in absorber per event = 0.07246 +- 5.162e-08
Number of secondaries per event : Gammas = 3.22e-06; electrons = 0.0001295; positrons = 0.0001209
Number of events with the primary particle transmitted = 99.98 %
Number of events with at least 1 particle transmitted (same charge as primary) = 99.98 %
Number of events with the primary particle reflected = 0 %
Number of events with at least 1 particle reflected (same charge as primary) = 0 %
MultipleScattering:
 rms proj angle of transmit primary particle = 0 mrad (central part only)
 computed theta0 (Highland formula)
                                            = 0 mrad
 central part defined as +- 0 mrad; Tail ratio = 0 %
... write Root file : luxe_gamma17GeV_beamMC_N6e9div100_TargetW_wire_d10mkm_Magnet1T_r01.root - done
... close Root file : luxe_gamma17GeV_beamMC_N6e9div100_TargetW_wire_d10mkm_Magnet1T_r01.root - done
```

Tmelting =1726K for Ni

for Ni wire,  $\oslash$  1  $\mu$ m,  $\Delta T \sim 10^{-12}$  K

#### N OF PHOTONS FROM MC

• emulating the wire, detector on distance of 10m from IP

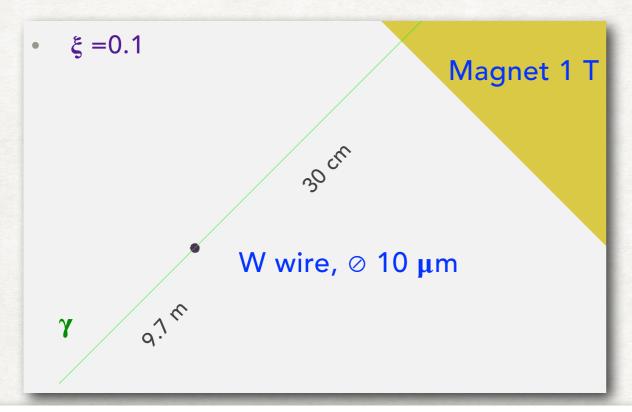


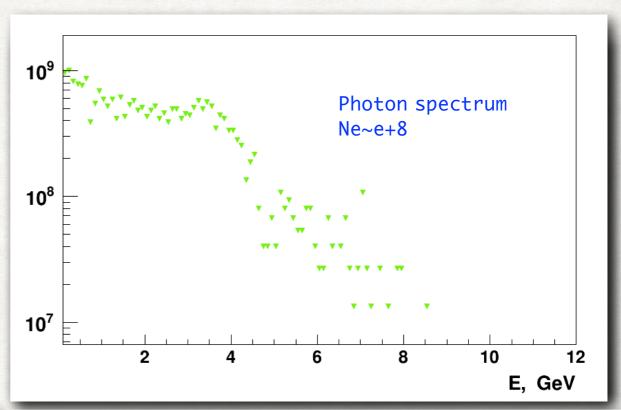
Ngamma in	case of wire
ξ	Νγ
0.1	5E+05

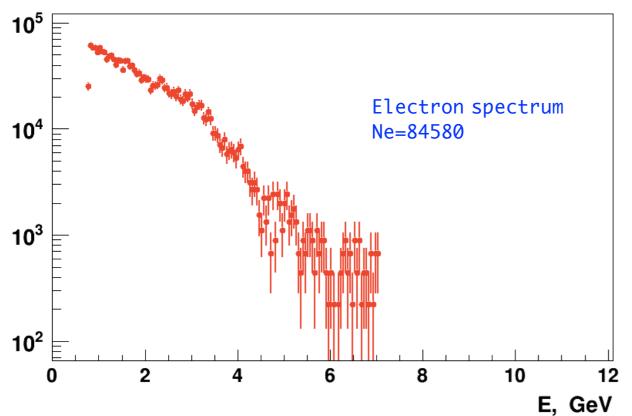
less but still a lot

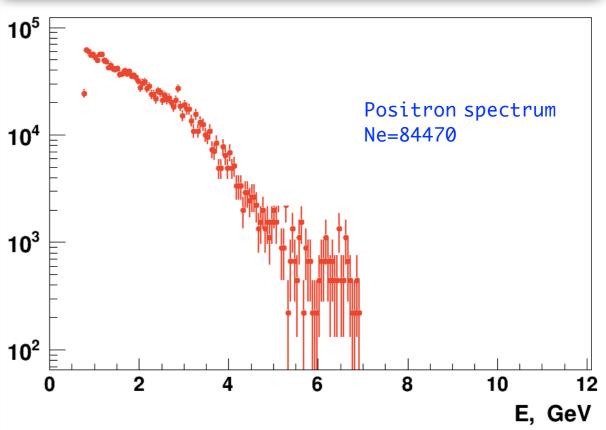
Ngamma in case of foil			
1e 35 fs (1BX)	Νγ		
2.39	1.49255E+10		
8.43	5.26758E+10		
16.29	1.01825E+11		
24.41	1.52579E+11		
	1e 35 fs (1BX) 2.39 8.43 16.29		

#### GEANT4 SIMULATION FOR THE WIRE CONVERTER









#### WHAT'S DONE & WHAT'S NEXT

- Estimated the absolute number of forward photons: from theory and MC+GEANT4 simulation: very high fluxes
- ❖ It is not trivial to restore the position of kinematic edges for n>1 for the real case scenario
- \* Non-uniform Laser Intensity ( $\xi$ ) makes the kinematic edges from different n not visible, especially for high  $\xi$
- Preliminary studies of the feasibility of usage W wire as converter target. For nominal XFEL beam the  $\xi$  =0.1, 10 m from IP, the number of e ~8e4.
  - \* this number will be ~1e2-1e3 for less intensive XFEL beam which is possible by tuning its gun;
  - \* to go further from IP
  - \* to study gas jet target
- \* for the BPPP monitoring the number of e+e- after the conversion for the wire is well manageable (~100).

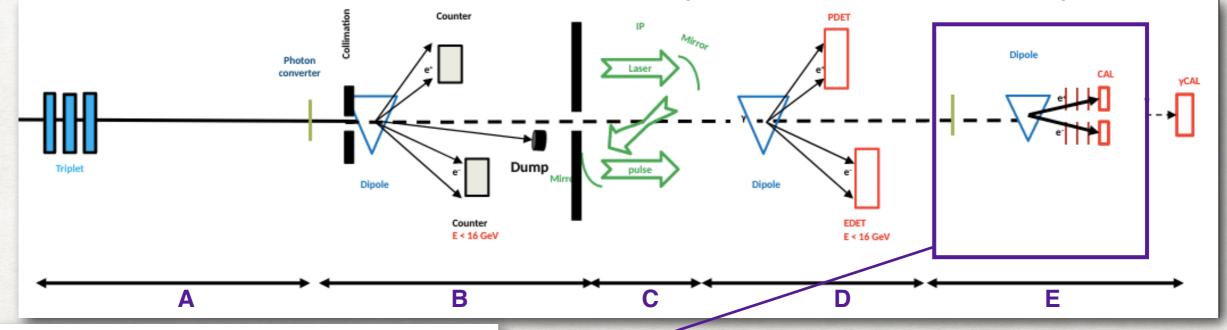
## BACK UP

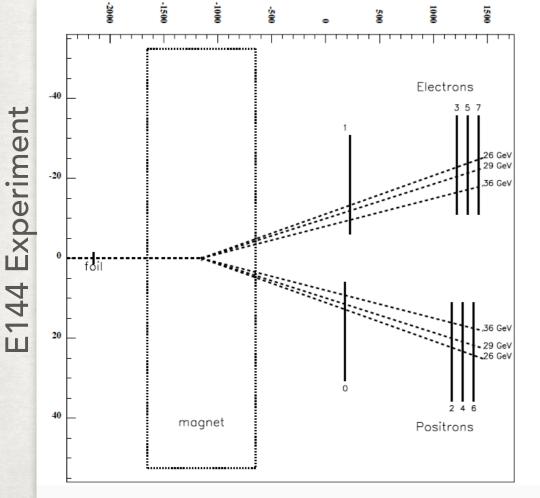
#### OUTLINE

- layout for FDS of the LUXE experiment
- HICS and the absolute number of forward photons
- method to study the photon-conversion data
- spectra from MC
- Geant4 simulation for the converter

#### LAYOUT FOR FDS OF THE LUXE EXPERIMENT

Photons produced at IP1 proceed down their own beamline through the converter foil and the tracking spectrometer



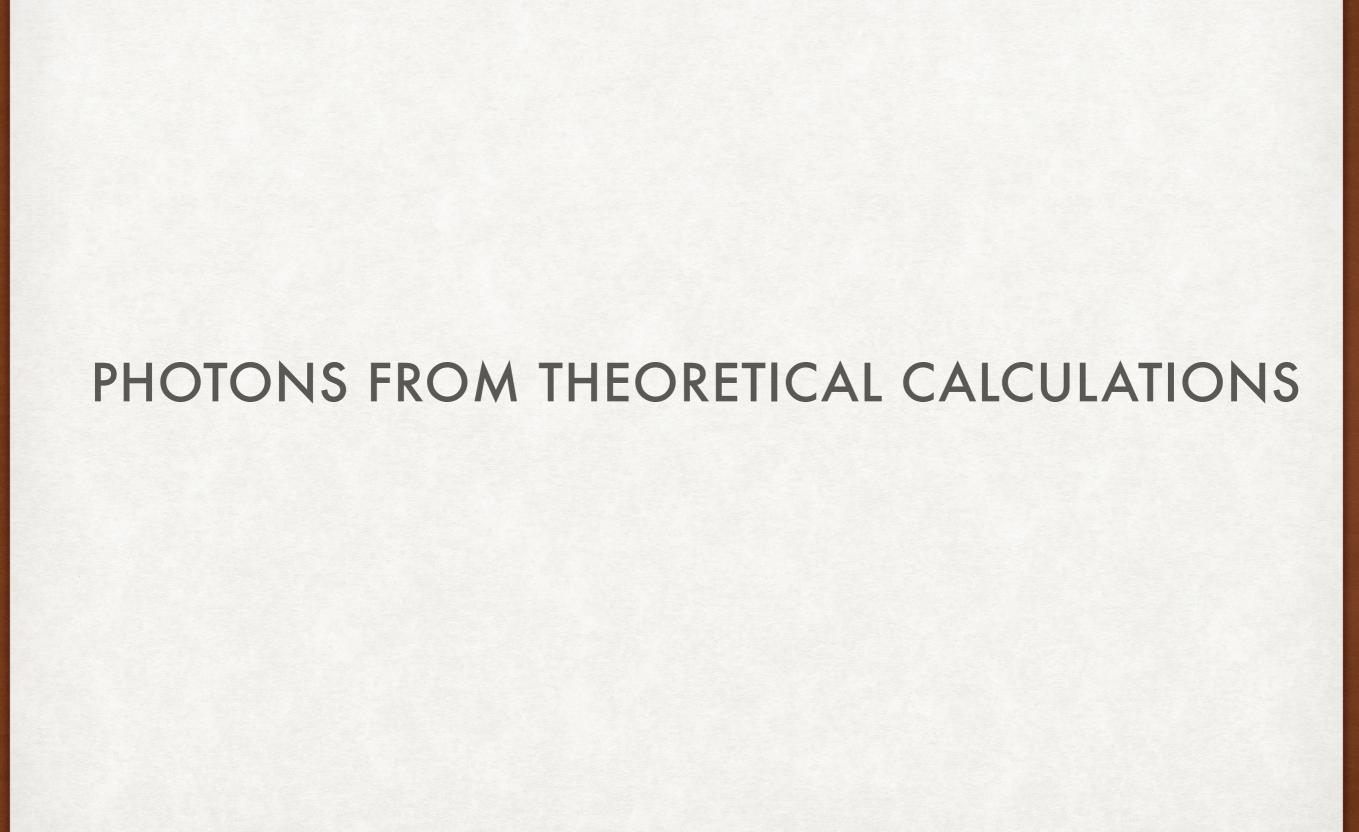


- $e + n\omega \rightarrow e + \gamma$  HICS  $\rightarrow$  Non-linear Compton
- $\gamma + n\omega \rightarrow e^+ + e^-$  BPPP  $\rightarrow$  monitor brem photons

#### The experiment should have the capability:

- to detect the presence of particles scattered at different orders of n
- · to measure their overall rate
- to resolve the detailed shape of their spectra to some extent
- to correlate these measurements with an estimate of the intensity parameter

The observation of tracks created by photons above the n=1 kinematic edge, which could not arise through multiple n=1 scattering, could demonstrate unambiguously the non-linear Compton scattering process



#### HICS DIFFERENTIAL TRANSITION PROBABILITY VS RADIATED PHOTON ENERGY

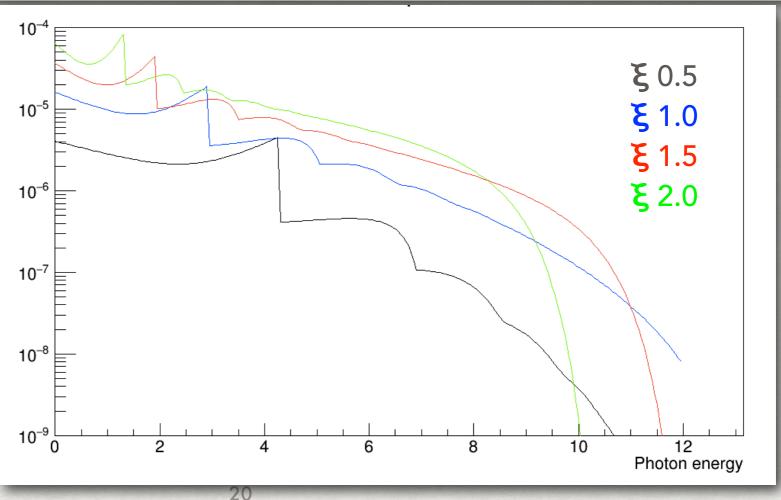
per initial particle per 100 fs 800 nm laser. 17.5 GeV initial electrons, 0.9\*Pi crossing angle

# data produced of HICS/IPW/circularly polarized with Mathematica by Anthony Hartin

$$\begin{split} &\Gamma_{\text{HICS}}\!=\!-\frac{\alpha m^2}{\epsilon_{\text{i}}} \sum_{n=1}^{\infty} \int_{0}^{u_n} \frac{du}{(1+u)^2} \bigg[ \mathbf{J}_n^2(z_u) \!-\! \frac{\xi^2}{4} \, \frac{1+(1+u)^2}{1+u} \big( \mathbf{J}_{n+1}^2 + \mathbf{J}_{n-1}^2 - 2 \, \mathbf{J}_n^2 \big) \bigg] \\ &z_{\text{U}} \!\equiv\! \frac{m^2 \xi \sqrt{1+\xi^2}}{k \!\cdot\! p_i} [u(u_n\!-\!u)]^{1/2}, \quad u_n \!\equiv\! \frac{2(k.p_i) \, n}{m^2 (1+\xi^2)}, \quad \xi \!\equiv\! \frac{e \, |A|}{m} \end{split}$$

differential transition rate per electron per 100 fs.

Increasing \( \xi\$ increases the HICS rate, but suppresses the photon energy (the mass shift)



#### ABSOLUTE NUMBER OF PHOTONS

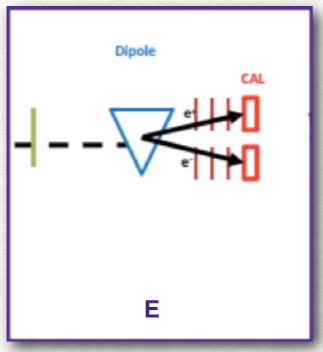
production rate for the electron bunch 6.25e+09 and laser pulse t=35 fs estimated from theoretical calculations

ξ	1e 35 fs (1BX)	Νγ
0.5	2.39	1.49255E+10
1	8.43	5.26758E+10
1.5	16.29	1.01825E+11
2	24.41	1.52579E+11

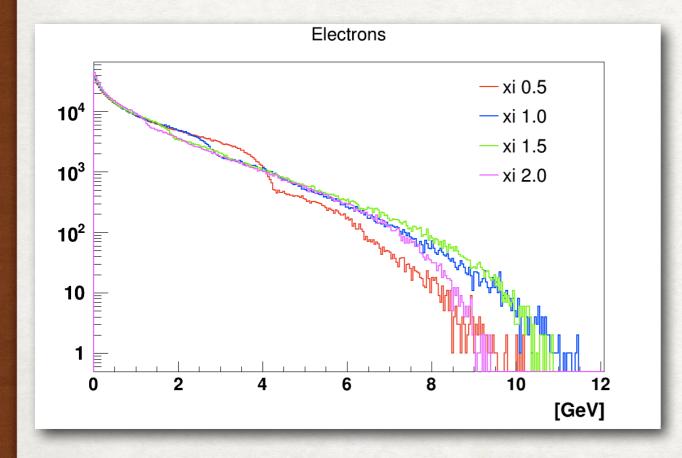
The transverse structure of the laser field is not taken into account in the data and it is assumed that the laser field is uniform in transverse plane and it is essentially the same for all electrons -> It could be accounted for in MC

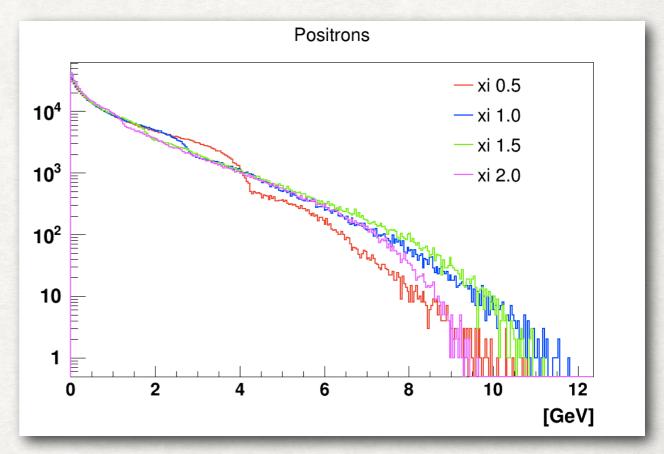
If the target thickness is 1% of X0 at this laser intensities ~ 1e8-1e9 e+epairs would enter the pair spectrometer in each laser pulse

## THE ELECTRON AND POSITRON SPECTRA FROM CONVERSION OF FORWARD PHOTONS INTO THE PAIRS FOR DIFFERENT ξ FROM GEANT4

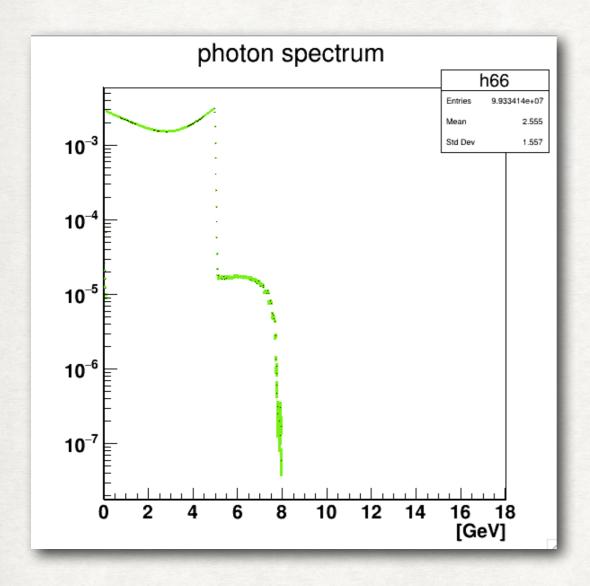


- target material W foil
- thickness 35 um
- 1e8 photons



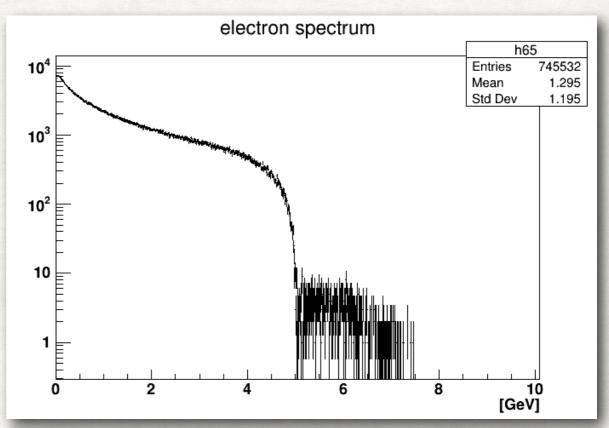


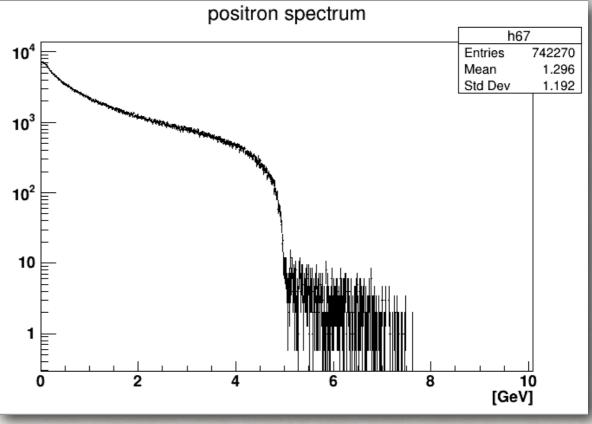
#### FORWARD PHOTONS IN GEANT4



target: Tungsten foil, 0.35 um 1e8 photons,  $\xi = 0.5$ 

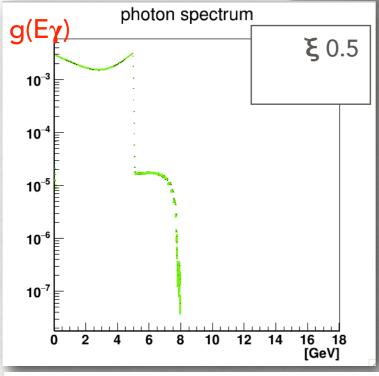
HUGE fluxes, for nominal beam ~ 1e+6 hard to measure energy of individual particles

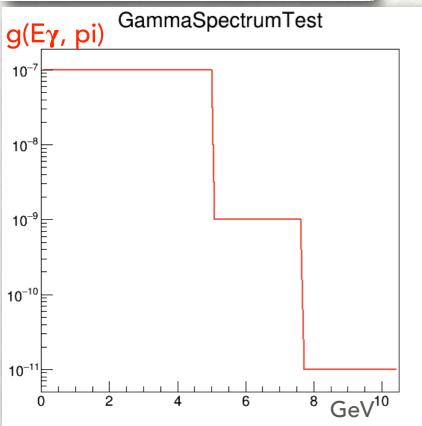




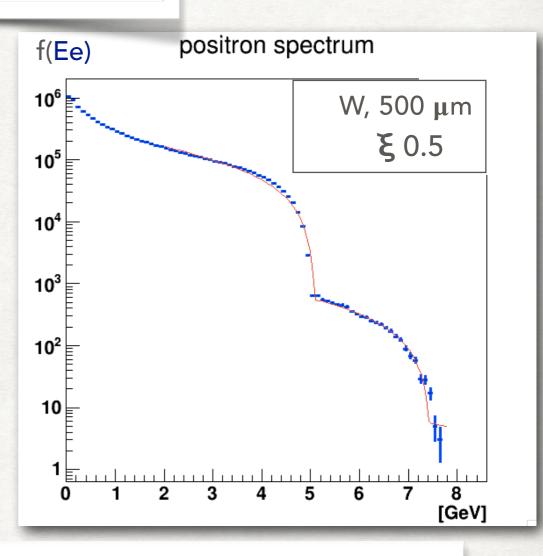
#### METHOD OF PHOTON SPECTRUM RESTORATION

$$f(Ee) = \int \sigma(E\gamma, Ee)g(E\gamma)dE\gamma$$





The single-particle spectrum obtained in GEANT4 is compared to a model spectrum calculated by convolving the trial photon spectrum with the Bethe-Heitler cross section

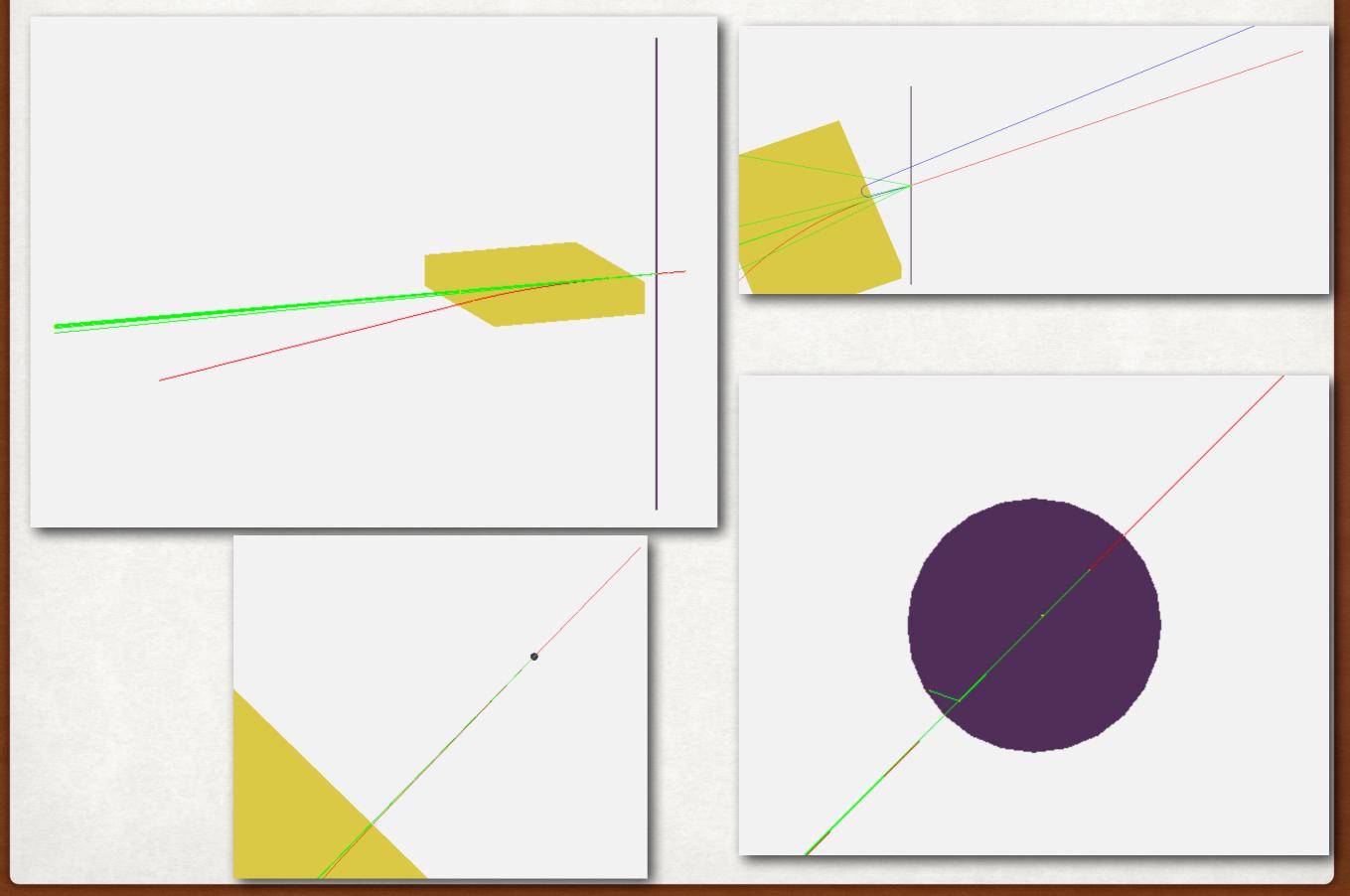


 $\int \sigma(E\gamma, Ee)g(E\gamma, p1, p2)dE\gamma$ 

fitting allows finding the **the kinematic edges** quite well

but this is done for the theoretical curve with uniform intensity

#### GEANT4 SIMULATION FOR THE WIRE CONVERTER



#### BETHE-HEITLER PAIR SPECTRUM

The classical Bethe-Heitler formula is currently used: H.Bethe, W.Heitler, Proc.Roy.Soc.A146 (34)83

$$\Phi \left( \mathbf{E}_{0} \right) d\mathbf{E}_{0} = \frac{\mathbf{Z}^{2}}{137} \left( \frac{e^{2}}{mc^{2}} \right)^{2} 4 \frac{\mathbf{E}_{0+}{}^{2}\mathbf{E}_{+}{}^{2} + \frac{2}{3}\mathbf{E}_{0}\mathbf{E}_{+}}{(h\nu)^{3}} d\mathbf{E}_{0} \left( \log \frac{2\mathbf{E}_{0}\mathbf{E}_{+}}{h\nu mc^{2}} - \frac{1}{2} \right).$$

energies involved are large compared with mc<sup>2</sup>

25 20 15 10 5 10 2 4 6 8 10 12 14 16 E+ The idea - to check if any photon spectrum could be restored if we have the classical BH

